**Educational and Recreational Camp "Politekhnik-4"**

Peremohy Street 1, Zozuli village, Zolochiv district, Lviv region.

The conference will take place from May 16th to 19th, 2024, at the premises of the educational and recreational camp "Politekhnik-4" in the village of Zozuli, located 80 km from Lviv and 5 km from Zolochiv.

"Politekhnik-4" is situated in a picturesque corner of Lviv region, surrounded by pine forests. Beautiful nature, clean air, vast forest areas, and unique plant species contribute to a comfortable stay in cozy rooms. In the camp and its vicinity, various activities can be enjoyed, including hiking, while admiring the surrounding mountains.

"Politekhnik-4" offers double and triple rooms, as well as suites and luxury accommodations. Each building has facilities for cooking and dining.

**Travel arrangement**

There are several interesting places worth visiting.

**Zolochiv Castle** (5 km from the camp) is one of the most well-known tourist attractions in Zolochiv. The castle was founded in the 17th century and features fortification architecture. Visitors can explore its walls, towers, and interior spaces, which recreate a historical atmosphere.

**Olesko Castle** (50 km from the camp) is renowned for its unique architecture that combines elements of fortification with Renaissance and Baroque styles.

**Pidhirtsi Castle** (16 km away) is located near Zolochiv. It was constructed in the 16th century and represents a vast fortress with towers and defensive structures.

You can find more information: [http://lvivgallery.org.ua/museums/muzyapovidnyk-zolochivskyy-zamok](http://lvivgallery.org.ua/museums/muzyapovidnyk-zolochivskyy-zamok)

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**Paper submission**

Length of papers are from 4 to 6 full pages.

The full paper should be prepared in WinWord format with page set up to A4 (210 x 297 mm) size paper.

Full paper should be submitted to the Organising Committee only in electronic form (Microsoft Word).

The required format is available on the Conference Web Page. Authors are asked to indicate the topic into which their papers fall.

Papers will be printed in the proceedings directly from the files submitted by the authors.

All accepted papers and oral (or poster) presenting at MEMSTECH-2024 will be submitted for revision to IEEE Xplore Digital Library. “No-show” papers won’t be submitted for inclusion in IEEE Xplore Digital Library.

**Language**

The working language is English.

**Registration fees**

<table>
<thead>
<tr>
<th>Standard</th>
<th>250 Euro</th>
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</thead>
<tbody>
<tr>
<td>Students and PhD students</td>
<td>175 Euro</td>
</tr>
<tr>
<td>IEEE Members</td>
<td>200 Euro</td>
</tr>
<tr>
<td>IEEE Students and PhD students</td>
<td>140 Euro</td>
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</tbody>
</table>

For participants from Ukraine, if the number of foreign authors of the article does not exceed 50%, discounts up to 100% are provided.

**Important dates**

**March 15, 2024** Deadline for final Camera-Ready Papers submissions (in English).

**April 30, 2024** Notification of Papers acceptance.
International programme committee

- M. Andriychuk: Pidstryhach Institute for Applied Problems in Mechanics and Mathematics NASU, Ukraine
- M. Banas: AGH-University of Science and Technology, Poland
- A. Dziedzic: Wroclaw University of Technology, Poland
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Organized by

- IEEE Ukraine Section (West) MTT/ED/AP/EP/SSC Societies Joint Chapter
- Lviv Polytechnic National University, CAD Department, Ukraine
- IEEE Ukraine Section (West) MTT/ED/AP/EP/SSC Societies Joint Chapter
- IEEE Ukraine Section IE/PE/PEL Societies Joint Chapter
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Organized committee

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Topics include, but not limited to

Microelectromechanical Systems
- Micro-Actuators and Sensors,
- MEMS Fabrication technology,
- Materials and Designs for MEMS,
- Optics and Bio-Medical Engineering,
- Environmental Monitoring Sensors,
- Microfluidic and hydraulic micro-actuators,
- Micro telemanipulation, and Standards Appropriate to MEMS,
- Multiple Device Chips,
- Micro-Wearable Devices.

Electronic Design Automation
- Electronic Design Aids,
- Models and Methods for Radioelectronics Device and Systems
- Embedded Systems Design and Implementation
- Specialized Systems and Devices

Visa policy of Ukraine

Citizens of most countries in Europe, North America and Asia do not need visa to enter Ukraine. The list of countries which have Visa-free Movement Regime with Ukraine can be found at:


Inquiries

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